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By:

LINDA E. HASTINGS

Any fee due as a result of this paper, not covered by an enclosed check, may be charged on Deposit Acct. No. 50-1290.

Attorney Docket No.: NECF 18.591 (100806-17366)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventor: Takaaki NAGAI

Serial No.: 09/837,734

Filed: April 17, 2001

Title: **NON-VOLATILE SEMICONDUCTOR STORAGE APPARATUS AND MANUFACTURING METHOD THEREOF**

Examiner: Douglas W. Owens

Group Art Unit: 2811

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO OFFICE ACTION**

SIR :

In response to the Office Action dated October 24, 2003, the period for responding thereto expiring after January 24, 2004, the period for response not being extended for more than three months, please amend the subject application as follows: